			H.E
	Application No.	Applicant(s)	
Notice of Allowability	10/632,598	SHEPHERD ET AL	
	Examiner	Art Unit	
	Michael K. Luhrs	2824	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT F of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED i i) or other appropriate comm RIGHTS. This application is	n this application. If not includ unication will be mailed in due	ed course, THIS
1. This communication is responsive to 18 February 2005.			
2. ☑ The allowed claim(s) is/are <u>1-26</u> .			
3. The drawings filed on are accepted by the Examin	er.		
4. Acknowledgment is made of a claim for foreign priority to a) All b) Some* c) None of the:  1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)).  * Certified copies not received:	re been received. re been received in Application	on No	ition from the
Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDONI THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		e a reply complying with the re	quirements
<ol> <li>A SUBSTITUTE OATH OR DECLARATION must be subr INFORMAL PATENT APPLICATION (PTO-152) which given</li> </ol>			OTICE OF
6.   CORRECTED DRAWINGS ( as "replacement sheets") mu  (a) ☐ including changes required by the Notice of Draftsper  1) ☐ hereto or 2) ☐ to Paper No./Mail Date  (b) ☒ including changes required by the attached Examiner  Paper No./Mail Date 11/18/04. Corrections pro  Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in  7. ☐ DEPOSIT OF and/or INFORMATION about the deport attached Examiner's comment regarding REQUIREMENT	rson's Patent Drawing Review  r's Amendment / Comment of the proced 2/18/05 approx  1.84(c)) should be written on the header according to 37 Classit of BIOLOGICAL MAT	r in the Office action of oved by examiner) he drawings in the front (not the FR 1.121(d).  ERIAL must be submitted. I	·
Attachment(s)  1. ☑ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)  3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date	6. ☐ Interview S Paper No. 7. ☒ Examiner's 8. ☒ Examiner's 9. ☒ Other <u>upda</u>	nformal Patent Application (PTo tummary (PTO-413), /Mail Date Amendment/Comment Statement of Reasons for Allo ated search.	
U.S. Patent and Trademark Office	SUPERVIS	ORY PATENT EXAMINER OLOGY CENTER 2800	

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#### **DETAILED ACTION**

1. This application is in condition for allowance except for the presence of claims 27-32 to device (product-by-process) (Group II) non-elected <u>without</u> traverse. Accordingly, claims 27-32 have been cancelled.

#### **EXAMINER'S AMENDMENT**

- 2. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.
- 3. Cancel claims 27-32.

The application has been amended as follows:

4. Claims 27-32 have been cancelled.

## Allowable Subject Matter

- 5. Claims 1-26 are allowed.
- 6. The following is an examiner's statement of reasons for allowance:

Regarding claim 1, there was no suggestion or teaching in a search of prior art for the introduction into the spark plasma, a volatile liquid in which particles are suspended. Pertinent art is clearly by the applicant[s] himself, see R-1 reference, on applicant's IDS dated 23 February 2004, namely, Shepard et. al. "Improved electroluminescence of spark-processed silicon by an aerosol-assisted technique" that was published in May of 2003, that indicates on p. 223, the novel aspect of the introduction of the volatile liquid having particles suspended, [directly] into the spark plasma.

Regarding claim 20, there was no suggestion or teaching in a search of prior art for the introduction into the spark plasma, a volatile liquid in which a salt of a heavy ion is dissolved.

Again the closest art is by the applicant[s], see above for claim 1.

7. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

# Response to Amendment

8. St. John et. al. use a syringe to apply a liquid solution right onto the semiconductor surface (line 8, "Abstract"), and see that St. John's liquid is permitted to evaporate at room temperature (see line 3, in the "Results and Discussion" section, p. 425, in St. John, et. al.) thus, apparently the solution is already sitting there, permitted to evaporate, prior to ever having the spark. This is different from present invention of introducing the volatile liquid <u>into</u> the spark plasma.

### Conclusion

9. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. R.E. Hummel and S.-S. Chang (1992) Appl. Phys. Lett. 61:1965-7, teach the method of spark-processing silicon. In USPN 5,733,662, Bogachek teaches an plasma coating process. See the spark-processing silicon apparatus by Spence, USPN 6,083,555. Serole USPN 5,723,027 and Upadhya et. al. USPN 5,468,357 and Hack et. al. USPN 6,113,746 (re: Hack et. al. is on applicant's I.D.S.) teach a coating process, powder reaction, porous article densification and altering magnetic properties, respectively.

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10. The complete description of spark-processing is found in Chapter 6 of Silicon Based

Materials and Devices, edited by Nalwa, Hari Singh, Academic Press, volume 1, pp. 238-266,

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wherein St. John is cited on p. 258, and [volatile] alcohols are used on p. 251; this chapter is by

the present inventor R.E. Hummel.

11. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Michael K. Luhrs whose telephone number is 571-272-1874.

The examiner can normally be reached on M-F, 8-5.

12. If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Richard T. Elms can be reached on 571-272-1869. The fax phone number for the

organization where this application or proceeding is assigned is 703-872-9306.

13. Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

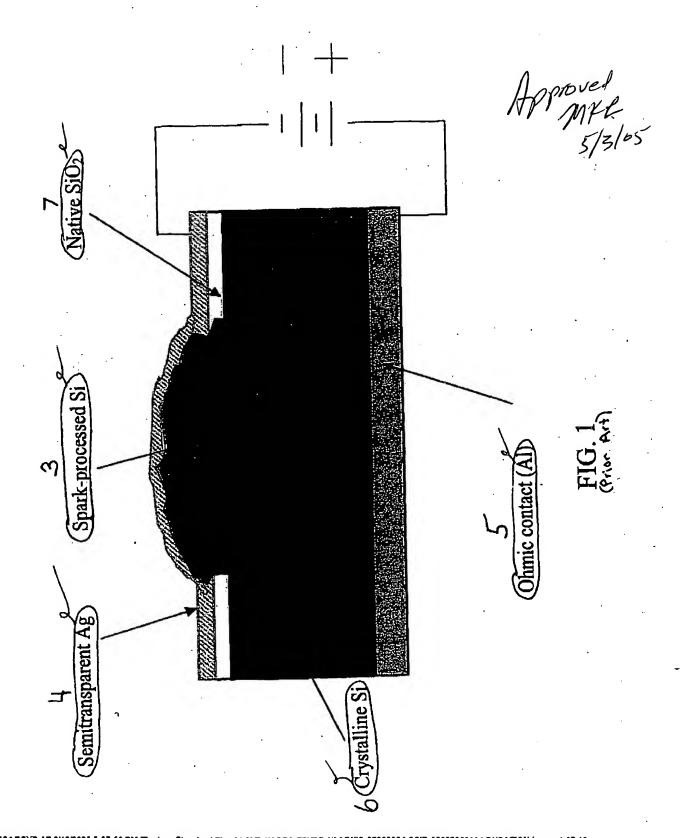
applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Michael K. Luhrs

6/13/05



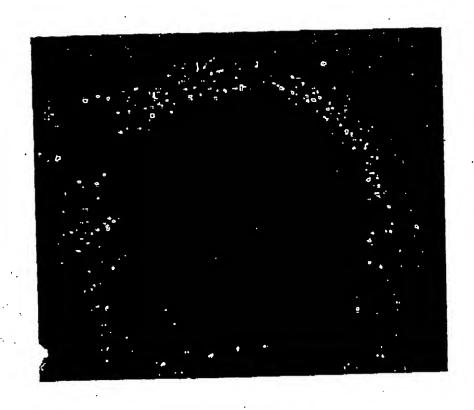
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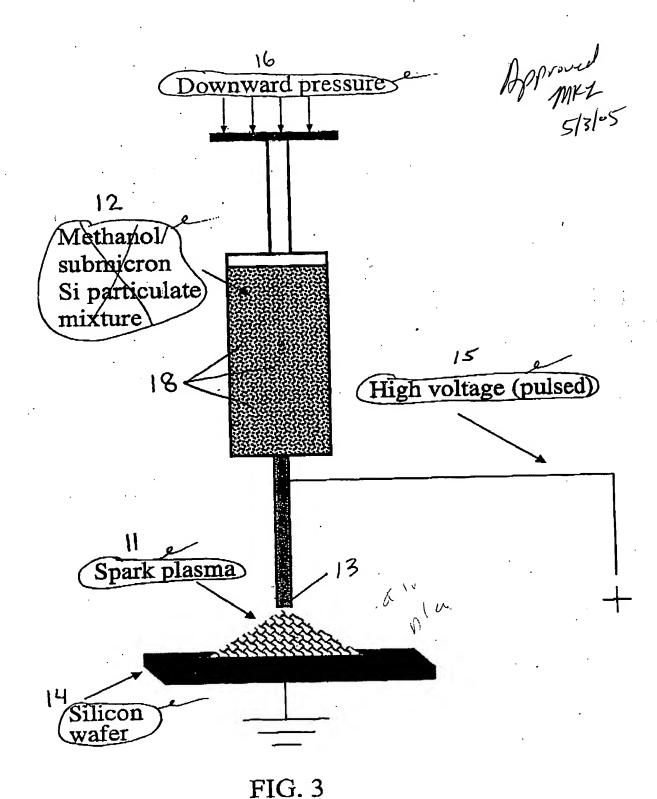
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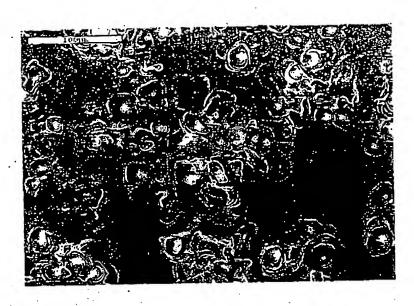




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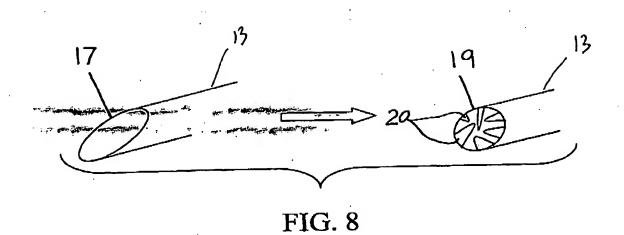
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FIG. 7C



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